

AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2800

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Haupt Docket No.: QIM 2003 P 51718 US  
Serial No.: 10/766,053 Art Unit: 2892  
Filed: January 28, 2004 Examiner: Thanh Y. Tran  
For: Method for N+ Doping of Amorphous Silicon and Polysilicon Electrodes  
in Deep Trenches

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT ACCOMPANYING RCE**

Dear Sir:

Applicant respectfully submits the following amendments and remarks in response to Examiner's Office Action dated March 20, 2008, which Action is made final and in response to the Advisory Action dated June 18, 2008. Applicant respectfully requests that these amendments and remarks be entered in pursuant to the provisions of 37 C.F.R. § 1.116.